# **Experimence Study of Trace Water and Oxygen Impact on SF**<sub>6</sub> **Decomposition Characteristics Under Partial Discharge**

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**Abstract** – It is common practice to identify the insulation faults of GIS through monitor the contents of  $SF_6$  decomposed components. Partial discharges (PD) could lead to the decomposition of  $SF_6$  dielectric, so new reactions usually occur in the mixture of the newly decomposed components including traces of  $H_2O$  and  $O_2$ . The new reactions also cause the decomposed components to differ due to the different amounts of  $H_2O$  and  $O_2$  even under the same strength of PD. Thus, the accuracy of assessing the insulation faults is definitely influenced when using the concentration and corresponding change of decomposed components. In the present research, a needle-plate electrode was employed to simulate the PD event of a metal protrusion insulation fault for two main characteristic components  $SO_2F_2$  and  $SOF_2$ , and to carry out influence analysis of trace  $H_2O$  and  $O_2$  on the characteristic components. The research shows that trace  $H_2O$  has the capability of catching an F atom, which inhibits low-sulfide  $SF_x$  from recombining into high-sulfide  $SF_6$ . Thus, the amount of  $SOF_2$  strongly correlates to the amount of trace  $H_2O$ , whereas the amount of  $SO_2F_2$  is weakly related to trace  $H_2O$ . Furthermore, the dilution effect of trace  $O_2$  on  $SOF_2$  obviously exceeds that of  $SO_2F_2$ .

**Keywords**: Partial discharge, SF<sub>6</sub>, Decomposed component concentration, Trace H<sub>2</sub>O and O<sub>2</sub>, Influence regularity

#### 1. Introduction

Different patterns and strengths of partial discharge (PD) always occur when SF<sub>6</sub> electrical equipment have some earlier insulation faults. High local electromagnetic energy caused by PD would cause SF<sub>6</sub> to decompose into several kinds of low-fluoride sulfide SF<sub>x</sub> [1-4]. If trace levels of H<sub>2</sub>O and O<sub>2</sub> exist in the equipment, the decomposed components would have further reactions with them and produce new characteristic components, such as SO<sub>2</sub>F<sub>2</sub>, SOF<sub>2</sub>, SO<sub>2</sub>, and so on [5-11]. The concentration and variation regularity of these characteristic components have close relationship with the patterns of insulation faults, as well as the trace levels of H<sub>2</sub>O and O<sub>2</sub> in gaseous SF<sub>6</sub>, making it more difficult to recognize the internal insulation deficiency when using them. Although the new gas SF<sub>6</sub> contains few impurities, trace levels of H<sub>2</sub>O and O<sub>2</sub> would enter the gas chamber as they are released from internal material or by penetration from the outside air over time [12]. There would be extra-trace levels of H<sub>2</sub>O and O<sub>2</sub> inevitably existing in the SF<sub>6</sub> electrical equipment. Hence,

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when extra-trace levels of  $H_2O$  and  $O_2$  exist in  $SF_6$  gas, learning about the decomposition mechanism from both theory and experiment under PD are necessary; obtaining the influence regularity and influence mechanism of trace  $H_2O$  and  $O_2$  on decomposed components is urgent. Furthermore, it is imperative to offer a amendment method considering the impacts of trace  $H_2O$  and  $O_2$  so that all of the aforementioned methods would lay a solid theoretical foundation for the correct identification and evaluation of the internal insulation faults of  $SF_6$  electrical equipment when making use of the decomposed components.

R. J. Van Brunt from the U.S. National Bureau of Standards conducted a systematic research about the SF<sub>6</sub> decomposition mechanism under PD. He studied the main source [13] of the O atom in SO<sub>2</sub>F<sub>2</sub>, SOF<sub>2</sub>, and SOF<sub>4</sub> using the isotopic tracer technique under the condition of needleplate electrode of corona discharge. His study pointed out that the O atom of SO<sub>2</sub>F<sub>2</sub> mainly comes from O<sub>2</sub>, the O atom of SOF<sub>2</sub> mainly comes from H<sub>2</sub>O, and the O atom of  $SOF_4$  comes from both  $O_2$  and  $H_2O$ . However, the paper also claimed that SO<sub>2</sub>F<sub>2</sub> obtains the O atom from H<sub>2</sub>O and SOF<sub>2</sub> obtains the O atom from O<sub>2</sub>. Nevertheless, the Van Brunt research used the same fixed concentration of H<sub>2</sub>O and O<sub>2</sub> without considering their levels of variation. According to Arrhenius' law of chemical reaction kinetics and mass action law [14], the chemical reaction rate depends on the reaction temperature, reactant concentration, and catalyst. Although Derdouri studied the impact of diverse concentrations of H<sub>2</sub>O on SF<sub>6</sub> gas under PD, there is a lack of explanation of the process [15].

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In this paper, the authors take advantage of the PD decomposition platform in the laboratory and study the concentration of decomposed SF<sub>6</sub> components and their variation trends under PD when different trace levels of H<sub>2</sub>O and O<sub>2</sub> are mixed with SF<sub>6</sub>. Moreover, the mechanism of how the various concentrations of trace water and oxygen act on the characteristic decomposed components from the angle of related chemical reaction rate is explained. Considering that random factors may lead to unfavorable results during the experiment, statistical inference using ANOVA is used to investigate the degree of impact of trace H<sub>2</sub>O and O<sub>2</sub> on decomposed characteristic components of SF<sub>6</sub>.

### 2. Decomposition Experiment and Quantitative Measurement

### 2.1 Experiment

This work studies the degree of influence of H<sub>2</sub>O and O<sub>2</sub> on decomposed characteristic components of SF<sub>6</sub> under PD from the statistical perspective. Hence, repeating the experiment independently n (here n=4) times under the same trace levels of  $H_2O$  and  $O_2$  (the level is  $A_i$ ) and making sure that each experiment group has only one variable. The procedure suggests that the concentration of O<sub>2</sub> is controlled below 100ppm (the rate of oxygen analyzer is 100ppm) in the experiment gas sample when the experiment on the influence of different trace levels of H<sub>2</sub>O was conducted. Likewise, the concentration of H<sub>2</sub>O is controlled below 150 ppm when the experiment on the influence of different trace levels of O2 was conducted. Experimental factors A (H<sub>2</sub>O) and B (O<sub>2</sub>) were subjected into seven experimental levels, as shown in Table 1.

Experiment material: SF<sub>6</sub> (purity: 99.99%, H<sub>2</sub>O≤100 ppm, O<sub>2</sub>≤100ppm), H<sub>2</sub>O, and O<sub>2</sub> were used as experiment materials. The experiment was conducted in the multifunction electrical decomposition of SF<sub>6</sub> equipment designed by our group, which is shown in Fig. 1 [16]. The main body of gas chamber is cylinder and both ends are oval structure to guarantee its air tightness. The volume of the chamber is approximately 10L and the maximum tolerance of air pressure can reach 0.5Mpa. The material of gas chamber is made of stainless steel for its corrosion resistance since the corrosive decomposed compositions of

**Table 1.** Factors affecting the by-product yields

Level	A (	H <sub>2</sub> O) in ppm	B (O <sub>2</sub> ) in ppm		
1	300		100	_	
2	700		220		
3	1000		460		
4	1300	$O_2 < 100 ppm$	900	$H_2O < 150 ppm$	
5	1600		2140		
6	1800		4960		
7	2100		10250		

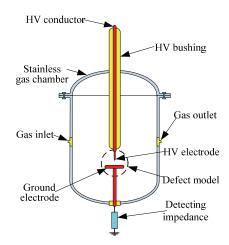


Fig. 1. SF<sub>6</sub> decomposition gas chamber

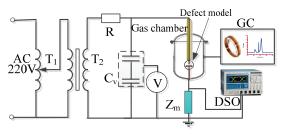


Fig. 2. Experimental system diagram

SF<sub>6</sub> may be produced during the experiment. Lead the HV conductor in the gas chamber through HV bushing and the model of insulation faults is positioned in the middle of the gas chamber so that it can connect with bottle of the HV conductor. Gas inlet and gas outlet is equipped to fill in SF<sub>6</sub> required in the experiment and gather the mixed gases sample after PD experiment.

The gas chamber was filled with 0.2 MPa of SF<sub>6</sub>. The experimental system diagram is shown in Fig. 2. The needle-plate electrode is needed to simulate the common insulation fault (metal protrusion insulation fault) in the equipment. Moreover, the experiment made use of noninductive detected impedance to send the pulse current signal to the WavePro 7100XL oscilloscope (Analog band: 1 GHz; sampling rate: 20 GHz; memory depth: 48 MB), which can monitor whether the PD is stable.

### 2.2 Experiment methods

This experiment uses needle-plate electrode model: spacing d is 10mm, curvature radius of needle tip is 0.3mm, diameter of ground electrode is 120mm and its thickness is 10mm. All the experiments are conducted at the same condition: the laboratory temperature is controlled at 15°C and relative humility at 50%, to avoid the impacts of different temperatures and humidity and ensure the experimental results are comparable. The specific experimental requisition and steps are listed as follows:

(1) Measurement of the initial voltage U<sub>s</sub> of the intrinsic

PD of the equipment (without putting insulation faults model) and the initial voltage  $U_0$  of the PD of the equipment (after putting the needle-plate electrodes). The respective measurements are  $U_s$ =45 kV and  $U_0$ =15 kV.

- (2) The gas chamber is vacuumized and then filled with new gas, SF<sub>6</sub>, and vacuumized again. This process is repeated two or three times for purification.
- (3) For the experimental procedure on the influence of H<sub>2</sub>O on the decomposed characteristic components of SF<sub>6</sub>, step (4) is used. Otherwise, for the experiment on the influence of O<sub>2</sub> on the decomposed characteristic components of SF<sub>6</sub>, step (5) is used.
- (4) The gas chamber is filled with the required amount of H<sub>2</sub>O by gas-syringe when the chamber is in vacuum condition, and subsequently heated in the equipment for 15 minutes. Another 15 minutes is spent to permit the H<sub>2</sub>O to undergo gasification and uniform distribution in the gas chamber. Step (6) follows.
- (5) The gas chamber is filled with the required amount of O<sub>2</sub> when the chamber is in vacuum condition. Another 15 minutes is spent to permit the full volume of O<sub>2</sub> to be uniformly distributed in the chamber.
- (6) The gas chamber is filled with SF<sub>6</sub> equivalent to a pressure of 0.25 MPa and put aside for 24 hours, so that H<sub>2</sub>O (or O<sub>2</sub>) and SF<sub>6</sub> are fully mixed.
- (7) The concentration of H<sub>2</sub>O and O<sub>2</sub> in the mixed gas is measured. If the concentration fails to meet the experimental standards, the procedure goes back to step (2). When the measured concentrations have satisfied the standards, the gas sample is collected and its intrinsic components are analyzed. The respective concentrations of the constituent gases are also measured. Afterward, the mixed gas pressure is adjusted to 0.2 MPa
- (8) The electrical wiring is connected as shown in Fig. 2. The experimental voltage is then gradually raised to 1.5U<sub>0</sub> (22.5 kV) and the PD decomposition experiment is conducted for 10 hours under this voltage. This part of the procedure ensures that the contents of the characteristic components are stable. The oscilloscope is used to monitor the electrical discharge of the needle-plate electrode.
- (9) After 10 hours, the concentration of the different decomposed components in the collected gas sample is analyzed using gas chromatograph (GC).
- (10) After measuring all the experimental parameters, the gas chamber is vacuumized and put aside for 1 hour to enable absorption of the decomposed components by the surface of the electrode. The time allowance is also aimed to fully extricate the decomposed components attached on the chamber wall and inhibit the impact of the remaining components of the ongoing experiment to the next experiment. The procedure is then repeated from step (2) for the next experiment.

# 2.3 Quantitative measurement of decomposed components

In the aforementioned experiments, the gas chromatograph (Varian CP-3800) was used to quantitatively measure the sample gas components produced by the discharge. The GC used the packed column Porapak QS and special capillary column CP-Sil 5 CB in parallel to separate the components in the mixture. Moreover, the chromatograph used PDHID double detectors (detection precision can reach up to 0.01ppm) to quantitatively detect each separated component. The chromatographic column was operated in the He (purity: 99.999%) carrier gas and the working conditions were flow rate, 2 mL/min; constant column

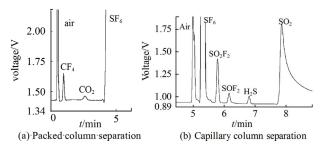


Fig. 3. Standard chromatogram

Table 2. The raw data of each experiment (ppm)

			$SO_2F_2$				
	300	13.43	14.13	10.52	11.42		
	700	14.11	13.32	15.56	14.01		
	1000	13.8	14.21	16.03	14.87		
	1300	15.48	16.91	11.48	12.06		
	1600	15.16	15.28	12.25	14.69		
	1800	18.66	15.33	16.25	17.72		
Trace-	2100	19.78	15.11	14.3	14.68		
$H_2O$	SOF <sub>2</sub>						
	300	32.66	30.66	25.64	30.01		
	700	38.93	39.68	41.38	39.83		
	1000	42.57	40.25	46.68	38.54		
	1300	46.9	52.64	48.01	48.43		
	1600	51.35	49.22	50.98	54.44		
	1800	61.88	55.91	54.71	58.89		
	2100	68.48	65.32	66.78	64.53		
	$SO_2F_2$						
	100	13.43	14.13	10.52	11.42		
	220	5.99	4.92	7.26	7.13		
	460	5.51	7.53	7	3.31		
	900	5.31	8.99	4.63	5.72		
	2140	8.69	9.98	4.87	5.79		
	4960	7.78	7.04	7.03	8.93		
Trace-O <sub>2</sub>	10250	15.62	4.87	14.36	9.54		
Trace-O <sub>2</sub>	SOF <sub>2</sub>						
	100	32.66	30.66	25.64	30.01		
	220	19.05	13.97	18.1	18.95		
	460	14.09	14.28	15.71	11.66		
	900	13.85	18.22	11.78	12.38		
	2140	15.82	16.81	10.99	11.2		
	4960	12.07	12.36	12.36	14.03		
	10250	26.85	10.99	14.95	16.09		

temperature, 40 °C; sample size, 1 mL; and split ratio, 10:1. Under these conditions, the packed column could separate air, CF<sub>4</sub>, and CO<sub>2</sub> effectively, and the special capillary column could separate air, SF<sub>6</sub>, SO<sub>2</sub>F<sub>2</sub>, SOF<sub>2</sub>, H<sub>2</sub>S, and SO<sub>2</sub> effectively. Fig. 3 shows the standard chromatograph.

This study used the external standard method combined with the standard chromatogram to qualitatively and quantitatively detect the decomposed components of SF<sub>6</sub>. Since the SO<sub>2</sub>F<sub>2</sub> and SOF<sub>2</sub> are the most important characteristic decomposed components of SF<sub>6</sub>[1, 3, 6-8, 13, 17, 18], the present study conducted intensive research on both. The raw data of each experiment as show in Table 2, Figs. 4 and 5 are the results of production amounts of the SO<sub>2</sub>F<sub>2</sub> and SOF<sub>2</sub> yields under PD at different levels of H<sub>2</sub>O and O2 in 10 hours (Each result is the production average value of four times repeated experiments under the same level of trace H<sub>2</sub>O or O<sub>2</sub>).

### 3. Influence of H<sub>2</sub>O and O<sub>2</sub> on Characteristic **Components**

Fig. 4 and Fig. 5 show that different levels of H<sub>2</sub>O and O<sub>2</sub> contribute to different concentrations of SO<sub>2</sub>F<sub>2</sub> and SOF<sub>2</sub> produced by SF<sub>6</sub> even under the same strength and time length of PD. Besides, the inevitable random factors which exert impacts on the experiment results should be considered in the experiment. Hence, the authors used

ANOVA to study the impact of the various levels of trace  $H_2O$  and  $O_2$  on characteristic components  $SO_2F_2$  and  $SOF_2$ and indentify the main influence factors on the production of SO<sub>2</sub>F<sub>2</sub> and SOF<sub>2</sub>.

#### 3.1 Analysis of variance

ANOVA was introduced by the American statistician Fisher in an agricultural experiment [19]. Subsequently, the method has been widely used in other areas, especially in data analysis of industrial experiments where the method ANOVA shows that the total variance  $(S_T^2)$  in the sample data can be divided into two parts: variance between groups  $(S_A^2)$  and variance within groups  $(S_E^2)$ .  $S_A^2$  is caused by controllable influential factors of different levels and  $S_E^2$  is caused by all random errors, that is  $S_T^2 = S_A^2 + S_E^2$ . The size of the difference between groups and the size of the difference within groups are compared to identify the degree of impact of each level on the experimental results, where  $S_T^2$ ,  $S_A^2$ , and  $S_E^2$  can be achieved from Equ. (1) to (3):

$$S_T^2 = \sum_{i=1}^r \sum_{j=1}^n (x_{ij} - \overline{x})^2$$
 (1)

$$S_A^2 = n \sum_{i=1}^r (\bar{x}_i - \bar{x})^2$$
 (2)

$$S_E^2 = \sum_{i=1}^r \sum_{j=1}^n (x_{ij} - \overline{x}_{i.})^2$$
 (3)

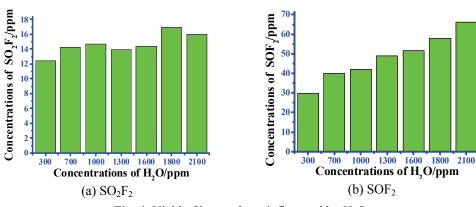
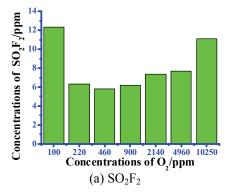


Fig. 4. Yield of by-products influenced by H<sub>2</sub>O



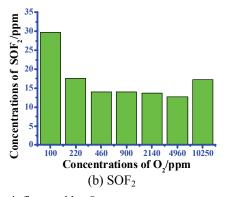


Fig. 5. Yield of by-products influenced by O<sub>2</sub>

In the above equations,  $x_{ij}$  is the *j-th* independent experimental result under the *i-th* concentration level of trace  $H_2O$  and  $O_2(A_i)$ , which means it is the result of the concentration of SOF2 or SOF2 when conducting the j-th experiment independently under the i-th concentration level of trace H<sub>2</sub>O and O<sub>2</sub>( $A_i$ );  $\bar{x}_i$  represents the group mean of the product of SO<sub>2</sub>F<sub>2</sub> or SOF<sub>2</sub> under the i-th concentration level of trace H<sub>2</sub>O and O<sub>2</sub> (A<sub>i</sub>) when conducting experiment n times independently;  $\bar{x}$ represents the mean of all the products of SO<sub>2</sub>F<sub>2</sub> or SOF<sub>2</sub> under the same influence factor (trace H<sub>2</sub>O or O<sub>2</sub>) in r experimental levels; and r is the number of influence factor (trace H<sub>2</sub>O and O<sub>2</sub>) concentration level. There are seven concentration levels in the present study, hence, r = 7. n is the number of times the experiment is repeated under the same condition, and in the current study, the experiment is repeated 4 times under the same concentration of trace H<sub>2</sub>O and  $O_2$ , thus, n = 4.

If all the experimental factors (trace  $H_2O$  and  $O_2$ ) have no significant influence in the experimental results,  $S_A^2$  is almost equal to  $S_E^2$  and statistics can prove that

$$F = \frac{S_A^2/(r-1)}{S_E^2/r(n-1)} \sim F(r-1, rn-r)$$
 (4)

In the equation, (r-1), r(n-1) are the degrees of freedom of  $S_A^2$  and  $S_E^2$ , respectively. Furthermore, let  $\overline{S}_A^2 = S_A^2 / (r-1)$ ,  $\overline{S}_E^2 = S_E^2 / r(n-1)$  and call them mean variance, so that equation (4) can be simplified as

$$F = \frac{\overline{S}_A^2}{\overline{S}_F^2} \sim F(r - 1, rn - r)$$
 (5)

ANOVA merely makes use of equation (5) to identify the degree of impact of each level (trace  $H_2O$  or  $O_2$ ) on the experimental results by comparing the differences between groups and the differences within groups. Given the significance level  $\alpha$ , when the calculated value of F is above the critical value  $F_{1-\alpha}(r-1,rn-r)$ , the influence factor (trace  $H_2O$  or  $O_2$ ) has significant influence on the experimental index (generation amount of  $SO_2F_2$  and/or  $SOF_2$ ). Furthermore, the bigger the F value of the sample, the more significant influence the factor has on the experimental index. Hence, specific attention has to be accorded on such influence factor, and additionally such influence factors should be controlled during practical production.

### 3.2 Analysis of the significance level of influence factors

Significance level  $\alpha$  is a critical probable value that represents the possibility to commit the fallacy of refusing the 'assumption' in a 'statistical hypothesis test' when using the sample information to draw conclusion. The

Table 3. Analysis of variance result

Decomposed component	Influence factor	Error	Degree of freedom	Mean variance $\overline{S}_A^2$ or $\overline{S}_E^2$	Value of F	Is influence significant?
SO <sub>2</sub> F <sub>2</sub>	H <sub>2</sub> O	$S_A^2$	6	16.82	3.52	not obvious
		$S_E^2$	21	4.44	3.32	
	$O_2$	$S_A^2$	6	26.69	4.44	yes
		$S_E^2$	21	6.01		
SOF <sub>2</sub>	H <sub>2</sub> O	$S_A^2$	6	392.34	87.94	especially
		$S_E^2$	21	7.26	07.94	
	$O_2$	$S_A^2$	6	140.03	11.98	especially
		$S_E^2$	21	11.69		

smaller the value of  $\alpha$ , the lesser the possibility of making the mistake of refusing the 'assumption'. When analyzing data in the field of general industry,  $\alpha = 0.05$ ; in the field of biology and medicine,  $\alpha = 0.01$ . In the present study which examines the degree of influence of trace  $H_2O$  and  $O_2$  on the main characteristic components of  $SF_6$  ( $SO_2F_2$  and  $SOF_2$ ) under PD, high precision is required. Hence, a significance level of  $\alpha = 0.01$  is adopted. The table of *F*-distribution critical values shows that  $F_{0.99}$  (6, 21) = 3.81. The result is presented in Table 3.

By collating and analyzing the results from Fig. 4, Fig. 5, and Table 3, the findings indicate that both  $H_2O$  and  $O_2$  exert an influence on the main characteristic components  $SO_2F_2$  and  $SOF_2$ . However, the products and the degree of influence of  $H_2O$  and  $O_2$  are different. The differences include the fact that  $H_2O$  has an obvious influence on  $SOF_2$  as the F value reaches 87.94, which is much larger than its influence on  $SO_2F_2$ . The formation of  $SOF_2$  is linearly proportional to the concentration of  $H_2O$ , but the formation of  $SO_2F_2$  has almost no relationship with the concentration of  $H_2O$ .  $O_2$  has a significant effect on both  $SO_2F_2$  and  $SOF_2$ , but the impact on  $SOF_2$  is significantly higher than the impact on  $SO_2F_2$ .

The existence of  $H_2O$  has an effect on the decomposition, as shown by Van Brunt. However, the effect caused by  $O_2$  I is different, which may be due to the fact that Van Brunt did his experiment under the same concentration of  $O_2$  and  $H_2O$  without taking into account the concentration of the reactants on the relevant reaction when exploring the sources of O in  $SOF_2$  and  $SO_2F_2$ .

# 4. The influence Mechanism of H<sub>2</sub>O and O<sub>2</sub> on the Characteristic Decomposed Components

Under PD, a series of characteristic components are produced by the reaction between the low-fluoride sulfide caused by the decomposition of  $SF_6$  and the trace levels of  $H_2O$  and  $O_2$  mixed in the gas. Van Brunt carried out a more detailed study of the  $SF_6$  decomposition mechanism under

PD with a needle-plate electrode mode. He proposed using the Plasma Chemical Model to explain the SF<sub>6</sub> decomposition mechanism under PD [8]. He pointed out that under the effect of the high-energy electrons generated by the PD, the following reaction will occur in SF<sub>6</sub>:

$$e + SF_6 \rightarrow SF_X + (6 - x)F + e, x = 1 \sim 5$$
 (6)

The high-energy electrons lead to the decomposition of  $SF_6$  to produce low-fluoride sulfide  $SF_x(x = 1 \text{ to } 5)$ . When no other impurities exist in  $SF_6$ ,  $SF_x$  will recover quickly with the following reaction:

$$SF_x + (6-x)F \rightarrow SF_6, x = 1 \sim 5$$
  
 $k = (1.5 \sim 2.4) \times 10^{11}$  (7)

Here, k is the rate constants of the reaction. However, during the long-term operation of the  $SF_6$  gas-insulated equipment, it is inevitable that different amounts of ultra-impurity gases, such as  $H_2O$  and  $O_2$ , will appear in the chamber, released by the internal material of the device and the penetration of external  $H_2O$  and  $O_2$  into the equipment. The impurities will lead to a series of more complex chemical reactions with  $SF_x$  and generate  $SO_2F_2$ ,  $SOF_2$ , HF,  $SO_2$ , and other compounds. Therefore, trace amounts of  $H_2O$  and  $O_2$  play a key role in the production of  $SO_2F_2$  and  $SOF_2$ .

# 4.1 Analysis of the characteristic decomposed component with the impact of H<sub>2</sub>O

 $\mathrm{H_2O}$  will undergo the following reaction under PD when  $\mathrm{H_2O}$  exists:

$$e + H_2O \rightarrow H + OH + e$$
 (8)

$$OH + OH \rightarrow O + H_2O \tag{9}$$

Meanwhile, the following reactions will occur among  $H_2O$  and  $SF_6$  decompositions:

$$F + H_2O \rightarrow HF + OH , k = 9.0 \times 10^{-12} cm^3/s$$
 (10)

$$F + OH \rightarrow FOH, k = 5.0 \times 10^{-13} \text{ cm}^3/\text{s}$$
 (11)

The reaction rate constants k of the reaction (10), (11) and reaction (7), are in the same order of magnitude. On the other hand, the mass action law [14] tells us that the chemical reaction rate r depends on the reactant concentration,  $C_i$ , the stoichiometry number,  $b_i$ , rate and the constant k, and the relationship is as follows:

$$r = k \prod_{i} c_i^{b_i} \tag{12}$$

Fortunately, under PD, for all of the chemical reactions where SF<sub>6</sub> and H<sub>2</sub>O are involved, the stoichiometry

number  $b_i$  is one. This finding suggests that the reaction rate r is proportional to the concentration of the reactants. Therefore, when traces of  $H_2O$  exist,  $H_2O$  has a capture function of F equivalent to the inhibition of the recovery reaction  $SF_x + (6-x) F \rightarrow SF_6$ .  $H_2O$  inhibits the low-fluoride sulfide  $SF_x$  (x = 1, 2, 3, 4, 5) composite to  $SF_6$ , so that the concentration of  $SF_4$ ,  $SF_5$ , and other components are increased. Additionally, under PD, the trace amount of  $H_2O$  has always been small compared with a variety of low-fluoride sulfide  $SF_x$ . Thus, the rates of reaction above are mainly determined by the concentration of  $H_2O$ . The higher the concentration of  $H_2O$ , the more severe the reaction and the more obvious the inhibition, as explained by the following reactions:

$$SF_5 + OH \rightarrow SOF_4 + HF, k = 1.1 \times 10^{-12} \text{ cm}^3/\text{s}$$
 (13)

$$SF_5 + O \rightarrow SOF_4 + F, k = 2.0 \times 10^{-11} \text{ cm}^3/\text{s}$$
 (14)

$$SOF_4 + H_2O \rightarrow SO_2F_2 + 2HF, k = 2.0 \times 10^{-21} \text{ cm}^3/\text{s}$$
 (15)

Formulas (8) to (11) and (13) to (14) show that when  $SF_6$  is mixed with  $H_2O$ ,  $H_2O$  plays a role in providing OH and O. Hence, the formation of  $SOF_4$  is promoted. Meanwhile, reactions (6) to (11) and (13) to (15) constitute a comprehensive reaction, which is the means by which  $SO_2F_2$  is generated. The generation capacity for  $SO_2F_2$  is determined by trot reaction (15), and with the increasing concentration of  $H_2O$ , the amount of  $SO_2F_2$  will slightly increase. However, with nearly 10 orders of magnitude of reaction rate in (15) than the rates of reaction in (10), (11), (13), and (14), and with increased concentration of  $H_2O$ , the increase of  $SO_2F_2$  is not obvious, as shown in Fig. 4(a).

On the other hand, the reaction between  $SF_4$  and  $H_2O$  will occur as follows [8]:

$$SF_4 + H_2O \rightarrow SOF_2 + 2HF$$
,  $k = 1.5 \times 10^{-19} \text{ cm}^3/\text{s}$  (16)

The reactions in (16) and (12) show that when the concentration of  $H_2O$  increases in  $SF_6$ , it will promote the production of  $SOF_2$ , as shown in Fig. 4 (b). However, the reaction rate constant k of reaction (16) is 2 orders of magnitude higher than reaction (15). Therefore, with the increased concentration of  $H_2O$  in  $SF_6$ , the rate of increase of the  $SOF_2$  produced is significantly higher than that of  $SO_2F_2$ , as shown in Fig. 4(b).

The effect of H<sub>2</sub>O on SF<sub>6</sub> decomposition characteristics under PD can be summarized as follows:

- (1)  $H_2O$  has a capture function of F which inhibits the low-fluoride sulfide  $SF_x$  (x = 1, 2, 3, 4, 5) composite to recombine with  $SF_6$ , leading to the increase in the main low-fluoride sulfide  $SF_5$ ,  $SF_4$ , and other components. The higher the concentration of  $H_2O$ , the more severe the reaction and the more obvious the inhibition.
- (2) H<sub>2</sub>O provides OH and O for the generation of oxygencontaining-sulfur-fluoride compounds, and promotes

the generation of the intermediate product SOF<sub>4</sub>.

(3) H<sub>2</sub>O plays a role in promoting the generation of the final and stable oxygen-containing-sulfur- fluoride compounds, such as SO<sub>2</sub>F<sub>2</sub> and SOF<sub>2</sub>. However, because the hydrolysis reaction rate of SF<sub>4</sub> is nearly two orders of magnitude higher than SOF<sub>4</sub>, the chemical reaction rate *r* of SF<sub>6</sub> and H<sub>2</sub>O under PD is proportional to the concentration of H<sub>2</sub>O. Thus, with the growth of the concentration of H<sub>2</sub>O in SF<sub>6</sub>, the growth rate of SOF<sub>2</sub> is significantly higher than that of SO<sub>2</sub>F<sub>2</sub>. From the foregoing generalizations, the impact of H<sub>2</sub>O on SOF<sub>2</sub> is significantly higher than the impact of SO<sub>2</sub>F<sub>2</sub>. Thus, the formation of SOF<sub>2</sub> has a positive linear association with the concentration of H<sub>2</sub>O.

# 4.2 Analysis of the impact of O<sub>2</sub> on the characteristic decomposed component

In the case of  $SF_6$  mixed with  $O_2$ , under the impact of high-energy electrons produced by PD, in addition to reactions (6) and (7), the following reactions will occur:

$$O_2 + e \rightarrow 2O + e \tag{17}$$

Besides the fact that the free state O generated by reaction (17) will react with SF<sub>5</sub> generated by PD and generate SOF<sub>4</sub>, the action below will happen and generate SOF<sub>4</sub>:

$$SF_4 + O \rightarrow SOF_4$$
 (18)

Then, both  $SOF_4$  and  $SF_4$  react with the  $H_2O$  released by the electrodes and the internal wall of the decomposition equipment and generate  $SO_2F_2$ , and  $SOF_2$ . While  $O_2$  exists,  $SF_2$  will be involved in the following reaction:

$$SF_2 + O_2 \rightarrow SO_2F_2$$
 (19)

At present, the reaction rate constant of reaction (19) has not been found yet. Reference [8] has given the maximum rate constant  $k=5.0\times10^{-16}$  cm<sup>3</sup>/s. Similarly, under PD, the stoichiometric number  $b_i$  of reaction (14) and the chemical reactions SF<sub>6</sub> and O<sub>2</sub> are involved in are also equal to one, and O<sub>2</sub> is always a small amount compared with a variety of low-fluoride sulfide SF<sub>x</sub>. Thus, the rate of reaction in (19) is proportional to the concentration of O<sub>2</sub>. The higher the concentration of O<sub>2</sub>, the more severe the reaction and the more SO<sub>2</sub>F<sub>2</sub> is generated.

For  $SO_2F_2$ , it can be seen from Fig. 5 (a) that when the concentration of  $O_2$  mixed in  $SF_6$  is less than 460ppm, the formation of  $SO_2F_2$  decreases with the increase of  $O_2$ . When the concentration of  $O_2$  is higher than 460ppm, the concentration of  $SO_2F_2$  is positively correlated with the concentration of  $O_2$  because an increase in the concentration of  $O_2$  in  $SF_6$  is equivalent to the dilution of  $SF_2$ ,  $SF_4$ ,  $SF_5$ , and other low-sulfur and fluorine F. Thus,  $O_2$ 

plays an inhibitory effect on the reaction:

$$SF_x + (6-x)F \rightarrow SF_6, x = 1 \sim 5$$

Although the concentrations of  $SF_2$ ,  $SF_4$ ,  $SF_5$ , and other low-sulfur components increase with the discharge and promote the reaction in (18) ~ (19), with the increase in the concentration of  $O_2$ , the concentration of  $H_2O$  released by the electrodes and the internal wall of the decomposition equipment is diluted, making the rate of reactions in (8) to (11) and (15) decrease. Reaction (19) is at lower status when competing with reaction (14), (15) and (18), thus leading to the reduction in the amount of  $SO_2F_2$  generated within 10 hours.

However, when the concentration of  $O_2$  is higher than 460ppm, with a further increase of O2, the rate of reaction in (18) undergoes a significant increase, and the rates of reaction in (8) to (11) and (15) are no longer significantly reduced. This time, since the concentration of O<sub>2</sub> is high, reaction (19) plays a dominant role in the generation of  $SO_2F_2$  when competing with reaction (14), (15), (18). Thus, when the concentration of  $O_2$  is above 460ppm, the yield of SO<sub>2</sub>F<sub>2</sub> increases with the increase of O<sub>2</sub>. Hence, with a low concentration of  $O_2$  (the concentration of  $O_2 < 460$ ppm), the dilution of the inherent moisture in the device is the most important factor that affects the formation of SO<sub>2</sub>F<sub>2</sub> and the stability of the decomposition under PD. Furthermore, the reactions in (8) to (11) and (15), (18) play leading roles in the formation of SO<sub>2</sub>F<sub>2</sub>. But at high concentration of  $O_2$  (the concentration of  $O_2 > 460$ ppm), reaction (19) plays a leading role in the generation of  $SO_2F_2$ , as shown in Fig. 5(a).

For  $SOF_2$ , its formation always decreases with the increase of  $O_2$ , but the reduction is not obvious when the concentration of  $O_2$  is higher than 460ppm. The reason for the practically unobservable reduction is that with the increase of  $O_2$  mixed in  $SF_6$ ,  $SF_2$ ,  $SF_4$ ,  $SF_5$ , and other low-sulfur, fluorine F undergoes a dilution process, thus playing an inhibitory effect on the reaction:

$$SF_x + (6-x) F \rightarrow SF_6, x = 1 \sim 5$$

Although the concentrations of SF<sub>2</sub>, SF<sub>4</sub>, SF<sub>5</sub>, and other low-sulfur components increase with the discharge, as the concentration of O<sub>2</sub> increases, the concentration of H<sub>2</sub>O released by the electrodes and the internal wall of the chamber is diluted at the same time. The rate of the reaction which plays a decisive role in the generation of SOF<sub>2</sub> is shown in the following reaction:

$$SF_4 + H_2O \rightarrow SOF_2 + 2HF$$
,  $k = 1.5 \times 10^{-19} \text{ cm}^3/\text{s}$ 

will decrease with the decrease in the concentration of  $H_2O$ . This phenomenon is most prominent when  $H_2O$  is diluted (the concentration of  $O_2 < 460$ ppm). With further dilution of  $H_2O$  (the concentration of  $O_2 > 460$ ppm), the

decrease in the reaction rate is not obvious, resulting in a significant decrease in the formation of SOF<sub>2</sub> with the increase of  $O_2$  when  $O_2$  is at a low concentration. When  $O_2$ is at a high concentration, the decrease in the formation of SOF<sub>2</sub> is not obvious with the increase of O<sub>2</sub>, as shown in Fig. 5(b).

In summary, the concentration of H<sub>2</sub>O in the reaction chamber decreases because of the dilution effect of  $O_2$ , resulting in the reaction rate of a series of reactions in which H<sub>2</sub>O decreases and the yield of SOF<sub>2</sub> decreases with the increase of O<sub>2</sub>. However, as O<sub>2</sub> promotes the formation of SO<sub>2</sub>F<sub>2</sub>, at the same time, the formation of SO<sub>2</sub>F<sub>2</sub> has a U-shaped relationship curve with the concentration of O2.

#### 5. Conclusion

- (1) Both H<sub>2</sub>O and O<sub>2</sub> influence the main characterisitic components SO<sub>2</sub>F<sub>2</sub> and SOF<sub>2</sub> during PD, but their byproducts and degrees of influence are different. The influence of H<sub>2</sub>O on SOF<sub>2</sub> is the most significant and the formation of SOF<sub>2</sub> has a positive linear relationship to the concentration of H<sub>2</sub>O while its influence on  $SO_2F_2$  is not obvious. The concentration of  $O_2$ influences the formation of both SO<sub>2</sub>F<sub>2</sub> and SOF<sub>2</sub> while the influence is much more obvious on SOF<sub>2</sub>.
- (2) H<sub>2</sub>O has the ability to catch an F atom and to inhibit the low-fluoride sulfide SF<sub>x</sub> by recombining to SF<sub>6</sub>, which increases the concentration of SF<sub>5</sub> and SF<sub>4</sub>. H<sub>2</sub>O offers OH and O for the formation of oxygenated-sulfur fluoride, which creates a favorable condition for the ultimate formation of SO<sub>2</sub>F<sub>2</sub> and SOF<sub>2</sub>. However, the hydrolysis rate of SF<sub>4</sub> is much higher than the hydrolysis rate of SOF<sub>4</sub> (nearly two orders of magnitude higher), as a result, the increase in the rate of SOF<sub>2</sub> is much higher than that of SO<sub>2</sub>F<sub>2</sub> when the concentration of H<sub>2</sub>O increases.
- (3) When the concentration of  $O_2$  is low, the content of  $H_2O$ in the equipment is the main factor which influences the fomation of  $SO_2F_2$ . When the concentration of  $O_2$  is high, the reaction  $SF_2 + O_2 \rightarrow SO_2F_2$  contributes mostly to the fomation of SO<sub>2</sub>F<sub>2</sub>, Thus, O<sub>2</sub> is the main factor. As for SOF<sub>2</sub>, an increase of concentration would diminish the H<sub>2</sub>O concentration, in which case O<sub>2</sub> becomes the most important factor in the decrease of SOF<sub>2</sub>.
- (4) The trace levels of H<sub>2</sub>O and O<sub>2</sub> play key roles on the formation of characteristic decomposed components of SF<sub>6</sub> during PD and have significant influence on the products, so it is necessary to study the decomposition mechanism of SF<sub>6</sub> under different concentrations of H<sub>2</sub>O and O<sub>2</sub> under the long run PD, and research on different concentrations will help achieve sufficient knowledge on what influences the regularity in the reactions to propose correction methods accordingly.

Acquiring sufficient knowledge on the decomposition mechanism and the factors that affect variation in the reactions under PD will lay a solid foundation in using decomposed components of SF<sub>6</sub> to assess insulation status and will support related repair guidelines for gas insulated electrical equipment.

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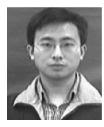
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